

UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 9283

| SERIAL NUM | IBER FILING OF | | r_371(c) | (c) CLASS | | GROUP ART UNIT | | | ATTORNEY DOCKET NO. | | |
|---|---|-------------|---------------------|-----------|------------------|----------------|---------------------------------------|-------------|------------------------|-------------|--|
| 10/573,49 | | | | | 438 | 2892 | | | 8074-1143 | | |
| | | RUL | .E | | | | | | | | |
| APPLICANTS Koichi Naniwae, Tokyo, JAPAN; | | | | | | | | | | | |
| ** CONTINUING DATA *********************************** | | | | | | | | | | | |
| ** FOREIGN APPLICATIONS ************************************ | | | | | | | | | | | |
| ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 10/12/2006 | | | | | | | | | | | |
| Foreign Priority claim | Yes No | ☐ Met after | | STATE OR | SHEETS | | TOTAL | | INDEPENDENT | | |
| 35 USC 119(a-d) conditions met Yes No Verified and Acknowledged /ERIC W JONES/ Examiner's Signature | | | Met after Allowance | | COUNTRY JAPAN | DRAWINGS 16 | | CLAII 48 | | CLAIMS 8 | |
| ADDRESS | | | | | | | | | | | |
| YOUNG & THOMPSON 209 Madison Street Suite 500 ALEXANDRIA, VA 22314 UNITED STATES | | | | | | | | | | | |
| TITLE | | | | | | | | | | | |
| Method of cleaning treatment and method for manufacturing semiconductor device | | | | | | | | | | | |
| | FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: | | | | | | ☐ All Fees | | | | |
| | | | | | | | ☐ 1.16 Fees (Filing) | | | | |
| FILING FEE RECEIVED | | | | | | | ☐ 1.17 Fees (Processing Ext. of time) | | | | |
| 3430 | | | | | | | ☐ 1.18 Fees (Issue) | | | | |
| | | | | | | | ☐ Other | | | | |
| | | | | | | | ☐ Credit | | | | |
| | | | | | | | | | | | |